



Image RCE/1700
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of:

KO et al.

Application No: 09/894,230

Filed: June 27, 2001

For: APPARATUS AND METHOD FOR
ARGON PLASMA INDUCED ULTRA VIOLET
LIGHT CURING STEP FOR INCREASING
SILICON-CONTAINING PHOTORESIST
SELECTIVITY

) Atty. Docket No: LAM2P257

) Examiner: J. Ruggles

) Group Art Unit: 1756

) Date: December 17, 2003

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being
deposited with the United States Postal Service as First
Class Mail to: Commissioner for Patents, Alexandria, VA
22313-1450, on December 17, 2003.

Signed:

Michael L. Gencarella

REQUEST FOR CONTINUED EXAMINATION (RCE) TRANSMITTAL

Mail Stop: RCE
Commissioner for Patents
Alexandria, VA 22313-1450

Sir:

1. Submission required under 37 C.F.R. § 1.114

- a. ☐ Previously submitted
- i. ☐ Consider the amendment(s)/reply under 37 C.F.R. § 1.116 previously
filed on _____.
- ii. ☐ Consider the arguments in the Appeal Brief or Reply Brief previously
filed on _____.
- iii. ☐ Other _____.
- b. ☒ Enclosed
- i. ☒ Amendment/Reply
- ii. ☐ Affidavit(s)/Declaration(s)
- iii. ☐ Information Disclosure Statement (IDS)
- iv. ☐ Other _____
- 12/23/2003 SZEWDIE1 00000137 09894230
- 01 FC:1801 770.00 OP
- 02 FC:1251 110.00 OP

2. Miscellaneous

- a. ☐ Suspension of action on the above-identified application is requested under 37
C.F.R. § 1.103(c) for a period of _____ months.
- b. ☐ Other _____

3. Fees

- a. ☒ Check in the amount of \$880.00 is enclosed for:
- i. ☒ RCE fee required under 37 C.F.R. § 1.17(e);
- ii. ☒ Extension of time fee (37 C.F.R. §§ 1.136 and 1.17); and
- iii. ☐ Other _____.
- b. ☒ The Director is hereby authorized to charge any fees, or credit any
overpayments, to Deposit Account No. 50-0805 (Order No. LAM2P257).

Date: December 17, 2003

Michael L. Gencarella, Esq.
Registration No. 44,703